

MAGNETIC BUBBLE DETECTORSBACKGROUND OF THE INVENTION:

1. Field of the Invention.

The invention relates to the field of magnetic bubble detection.

5 2. Prior Art.

In the fabrication of magnetic bubble (single wall domain) devices, particularly magnetic bubble memories, it is important to limit the number of connections that must be made between the memory substrate and external circuits. Also, it is
10 advantageous to use as few as possible external circuits and to have, for example, the same driving circuit power two bubble generators. In copending U.S. application Serial No. 25,848, filed April 2, 1978, entitled "Multiplexed Single Wall Domain Generators", (assigned to the assignee of the present
15 application), a system is described for multiplexing bubble generators.

There have been attempts in the past to multiplex bubble detector outputs. In one scheme, four chevron detectors are formed at different angular orientations. For example, the
20 detectors are oriented each 90 degrees from the other, like spokes of a wheel. Then, the detectors are coupled to a common sensing circuit. One problem with this scheme is described in conjunction with Figure 3a of the specification.

The present invention relates to a method for optimizing
25 the signal level output from each of the multiplexed bubble detectors. One process for adjusting the signal level from a magnetic bubble detector is described in copending U.S.

application Serial No. 163,574 filed June 27, 1980 entitled "Method for Adjusting Signal Level Output from Magnetic Bubble Detector", assigned to the assignee of the present application.

SUMMARY OF THE INVENTION:

5 According to the present invention there is provided in the fabrication of a magnetic bubble detector which includes a magnetoresistive detection element and a propagation element insulated from said detection element, a method for optimizing the output from said detection element comprising: controlling
10 the ratio of the width and thickness of said detection element such that said ratio is approximately equal to a predetermined number; whereby the output of said detection element is optimized.

BRIEF DESCRIPTION OF THE DRAWINGS

15 Figure 1 is a plan view of a prior art magnetic bubble detector.

 Figure 2 is a cross-sectional elevation view of a portion of the detector of Figure 1 generally taken through section line 2-2 of Figure 1.

20 Figures 3a - 3c illustrate various detector elements and the outputs from the elements.

 Figure 3a illustrates a chevron detector and the output from this detector.

 Figure 3b illustrates a bubble detector which includes a
25 separate detector element, and the output from this element when the element is disposed in the region of the leading edge of the propagation element.

 Figure 3c illustrates a bubble detector which includes a

separate detector element, and the output from this element when the element is disposed in the region of the trailing edge of the propagation element.

Figure 4 is a schematic of a detection apparatus.

5 Figure 5 is a cross-sectional elevation view illustrating processing steps used to define the detector element and to optimize its output.

DETAILED DESCRIPTION:

A magnetic bubble detection apparatus is described which
10 provides multiplexed outputs from two separate detectors. Two independent streams of bubbles are detected with separate detector elements and the resultant signal from these separate elements is sensed on a single pair of lines. This reduces the number of package pins required, and moreover, the number of sense amplifiers
15 needed for detection.

Referring now to Figure 1, a prior art bubble detector is illustrated which includes an expander section 10, a propagation element 12 which comprises a column of chevrons, a bubble trap defined between chevron columns 13 and 14, and an additional column
20 of chevrons 15. A magnetic bubble, as it is propagated past the element 12, is detected by an elongated detector element (strip of magnetoresistive material) disposed below element 12. As is generally the case, magnetic bubbles are moved into the detector of Figure 1 in the direction 20 under the influence of an in-plane
25 rotating magnetic field. As the bubbles are propagated past the column of chevrons 12, the resistance of the underlying detector element is changed, and this change is sensed. Bubbles are then propagated onto element 13 and become trapped between the elements 13 and 14.

An additional column of chevrons 15 which is identical to the column of chevrons 12, and an additional "dummy detector" element 17 which is identical to the detector 16 is disposed adjacent to the trap. Even though elements 15 and 17 do not receive and sense bubbles, they are affected by the rotating magnetic field. The signal from the element 17 is used as a reference signal to effectively cancel (reject) the effects of the rotating magnetic field on the element 16.

In Figure 2 only those layers of a memory or other device needed to view the detector of Figure 1 are shown. The structure is formed on a substrate 21 which is typically a garnet substrate. An ion implanted magnetic garnet (epitaxial layer 22) is employed on the substrate for the magnetic bubble storage layer. The single wall domains are moved in this layer as is well-known. A silicon dioxide layer 23 which is approximately 1500Å thick is formed over the epitaxial layer. Then the detector element 16 is fabricated on the layer 23 using ordinary photolithographic techniques from a magnetoresistive material such as permalloy.

An additional oxide layer is formed over layer 23 to insulate the detector 16 from the overlying permalloy members. This oxide layer 24 is approximately 1500Å thick. Then the permalloy propagation elements such as the column of chevrons 12 are formed over the oxide layer 24 in a well-known manner.

In Figure 3a, a prior art chevron detector 25 is illustrated which comprises a plurality of interconnected chevrons. When a bubble is moved through this chevron detector under the influence

of a rotating magnetic field, the waveform shown to the right of detector 25 results for each cycle of the rotating magnetic field. As can be appreciated, it is difficult to multiplex a number of outputs from detectors such as detector 25 because
5 of the resultant waveform.

In Figure 3b, a detector similar to the detector shown in Figure 1 is illustrated, however, the detector element 27 is disposed in the region of the leading edge of the propagation element 26. Assuming bubbles are moving in the direction of
10 arrow 29, they first reach a first edge of the element 26 (leading edge) and then are propagated to the opposite edge (trailing edge) of the element. For the relative location of the detector element 27 and propagation element 26 of Figure 3b, a bubble is sensed by the detector during the first part of each
15 cycle of the rotating magnetic field as shown to the right of elements 26 and 27 (ignoring the effects of the rotating magnetic field on the detector element).

In Figure 3, another propagation element 30 is illustrated with an underlying detection element 28. This time, however,
20 the detection element 28 is disposed in the region of the trailing edge of the element 30. In this position, a bubble is sensed towards the end of each cycle of the rotating magnetic field as indicated by the graph shown to the right of elements 28 and 30.

25 The appreciation that during a cycle of the rotating magnetic field a bubble can be sensed at different portions of this cycle (compare Figure 3b and Figure 3c) is put to use for multiplexing purposes.

Referring now to Figure 4, the detector elements of two detectors are coupled in a bridge circuit. Detector 1 of Figure 4 includes an expander section not illustrated which expands bubbles and propagate them into propagation element 32 (a column of chevrons). The bubbles are then propagated into a trap which is disposed between the column of chevrons 32 and the columns of chevrons 35. A magnetoresistive detection element 33 is disposed beneath the propagation element 32 in the region of the leading edge of the element 32. An identical element, dummy element 34, is disposed in the region of the leading edge of the column of chevrons 35. Element 33 is electrically coupled between contacts 45 and 47, and the dummy element 34 is coupled between the contacts 46 and 49. Referring briefly to Figure 2, for the detector 1 of Figure 4, the detector element 33 and dummy element 34 would be centered about the line 36 and again insulated from the overlying chevrons.

Detector 2 of Figure 4 again includes an expander section not illustrated which propagates bubbles into the propagation element 40. Disposed beneath the propagation element 40 is a detector element 41 which again comprises a magnetoresistive material. The element 41 is coupled between the contacts 48 and 51. The element 41 is in the general region of the trailing edge of the propagation element 40. A trap is disposed between the propagation element 40 and the column of chevrons 42. A dummy element 43 is disposed beneath the column of chevrons 42 in the region of the trailing edge of chevrons 42. This dummy element is connected between contacts 50 and 52. Referring briefly to Figure 2, the detector element 41 and element 43

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would be centered on line 37 for detector 2 of Figure 4. (Note that the precise location of the detector elements and dummy elements relative to the leading edge and trailing edge of the propagation element is not particularly critical.)

5 The layout (in terms of size and orientation relative to the rotating magnetic field) of elements 32 and 33 when compared to elements 35 and 34, respectively, is identical to provide proper electrical performances. The same is true for elements 40 and 41, and elements 42 and 43, respectively. (This, of course, is true for the prior art detector of Figure 1).

10 The detector 1 and detector 2 of Figure 4 are coupled in a bridge circuit. A potential is applied to the contacts 44 and 46. Contact 47 is coupled to contact 50, and contact 48 is coupled to contact 49. The contacts 51 and 52 are coupled to ground. In this bridge circuit, the dummy elements null out the effect of the rotating magnetic field on the detector elements and allow the bubbles passing through the propagation elements 32 and 40 to be sensed. The output signal from the detectors is taken from contacts 47 and 49 which contacts are typically coupled to package pins, and via lines on a printed circuit board to a sense amplifier.

15 By knowing the portion of a cycle of the magnetic field during which a bubble is detected (or not detected) the output from each of the detectors 1 and 2 is known.

20 Referring again to Figure 3, the output sensed from the bridge circuit of Figure 4 (and at the sense amplifier) consists of a graph of Figure 3b superimposed on the graph of Figure 3c. It is apparent that the signal caused by a bubble moving through element 32 of Figure 4 can readily be discerned from a bubble

moving through element 40 even though the bubbles move through these column of chevrons at the same time. The "quiet period" (no signal) region of Figure 3c falls within the period when a signal is generated in Figure 3b, and vice versa.

5 It has been found that the output from the detector elements such as detector elements 33 and 41 of Figure 4 can be optimized by having the width to thickness ratio of these elements equal to a predetermined number. By way of example, with a prior art chevron detector (Figure 3a), output signals
10 of approximately 5 mv are typical. By controlling the w/t ratio of the detector elements, output signals of approximately 20 mv are obtained. (This assumes the length of chevron detector is approximately equal to the length of the element 33 or 41.)

15 Through empirical determination it has been found that the ratio w/t for the detector element (see Figure 5) should be approximately equal to 100 for maximum output where a typical permalloy is used. (In the presently preferred embodiment, the permalloy comprises 81% nickel and 19% iron). Due to
20 process variations the w/t ratio can vary as much as + 20%. These variations, particularly at the extremes, substantially deteriorate the output from the detector elements.

During fabrication in the presently preferred process, the layer from which the detector element 61 of Figure 5 is etched,
25 is first formed over the oxide layer 60. (The detector element 61 corresponds to the elements 33, 34, 41 or 43 of Figure 4.)

After the fabrication of the layer, its thickness is checked, for example, by checking the sheet resistance of the layer. Once the thickness is known, the desired width is likewise known since the w/t ratio should be approximately 100. A photoresist layer

5 is formed over the permalloy layer and with an ordinary masking step, a masking member 62 is formed which is used to define the detector 61. Then the etching step used to etch the permalloy layer is controlled to provide an undercutting 64 under the photoresist member 62. This controlled undercutting

10 is allowed to continue until the desired width w is achieved. As is well-known, this etching can be quite precisely controlled.

The thickness of the permalloy layer is generally quite uniform over the entire wafer. Thus, all the detector elements

15 (and dummy elements) on a given wafer will require the same etching time and can be formed with one masking and etching step.

The same result can be achieved by first forming an extra thick permalloy layer from which the detectors are to be etched.

20 Then, after the etching with a photoresist member such as member 62 of Figure 5, the width to thickness ratio is measured.

It, of course, would be expected that the ratio w/t is less than 100 since the permalloy layer was intentionally made thick. The detector elements are then etched to decrease their thickness until the desired thickness is achieved. This etching is preferably done with ion milling with the entire wafer being subjected to such milling.

In our copending U.K. patent application No. 8133047 from which the present application has been divided there is described and claimed a magnetic bubble detection apparatus comprising: a first magnetic bubble detector including a first propagation element which propagates bubbles from its leading edge to its trailing edge under the influence of a rotating magnetic field, and a first detection element disposed in the region of said leading edge of said first propagation element and insulated from said element so as to sense the presence of a bubble as it is propagated through the region of said leading edge of said first propagation element; and, a second magnetic bubble detector including a second propagation element which propagates bubbles from its leading edge to its trailing edge under the influence of said rotating magnetic field, and a second detection element disposed in the region of said trailing edge of said second propagation element and insulated from said element so as to sense the presence of a bubble as it is propagated through the region of said trailing edge of said second propagation element; said first and second detectors being placed relative to one another such that the angles formed between said detectors and said rotating magnetic field are the same, whereby the outputs from said first detection element

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and second detector element may be multiplexed.



CLAIMS

1. In the fabrication of a magnetic bubble detector which includes a magnetoresistive detection element and a propagation element insulated from said detection element, a method for optimizing the output from said detection element comprising:

5 controlling the ratio of the width and thickness of said detection element such that said ratio is approximately equal to a predetermined number;

 whereby the output of said detection element is optimized.

2. The method defined by claim 1 wherein said detection
10 element comprises permalloy and said ratio is equal to approximately 100.

3. During the fabrication of a magnetic bubble detector which includes a magnetoresistive detection element and a propagation element insulated from said detection element,
15 a process for optimizing the output from said detection element comprising the steps of:

 determining the thickness of the layer from which said detection element is to be formed;

 forming a masking member over said layer to define said
20 detection element;

 etching said detection element from said layer, including
 controlling the undercutting of said detection element below
 said masking member so as to obtain a predetermined width of
 said detector element, said width being selected such that
25 the width to thickness ratio of said detection element is
 approximately equal to a predetermined number;

 whereby the output of said detection element is optimized.



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4. The process defined by claim 3, wherein said detection element comprises permalloy and said predetermined number is approximately 100.
 5. A method for optimizing the output from a magnetoresistive detection element substantially as hereinbefore described.
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